

## Environmental Protection Agency

## § 63.11871

Citation	Subject	Applies to subpart EEEEEEE	Explanation
§ 63.10(b)(2)(i)–(v), (d)(5) .....	Recordkeeping/Reporting Associated with SSM.	No.	
§ 63.10(c)(2)–(c)(4), (c)(9) .....	Reserved .....	No.	
§ 63.11 .....	Control Device Requirements	No.	
§ 63.12 .....	State Authority and Delegations.	Yes.	
§§ 63.13–63.16 .....	Addresses, Incorporation by Reference, Availability of Information, Performance Track Provisions.	Yes.	

### Subparts FFFFFFFF and GGGGGGGG [Reserved]

### Subpart HHHHHHHH—National Emission Standards for Hazardous Air Pollutant Emissions for Polyvinyl Chloride and Copolymers Production

SOURCE: 77 FR 22906, Apr. 17, 2012, unless otherwise noted.

#### WHAT THIS SUBPART COVERS

#### § 63.11860 What is the purpose of this subpart?

This subpart establishes national emission standards for hazardous air pollutants emitted from the production of polyvinyl chloride and copolymers at major sources. This subpart also establishes requirements to demonstrate initial and continuous compliance with the emission standards.

#### § 63.11865 Am I subject to the requirements in this subpart?

You are subject to the requirements in this subpart if you own or operate one or more polyvinyl chloride and copolymers production process units (PVCPU) as defined in § 63.12005 that are located at, or are part of, a major source of hazardous air pollutants (HAP) emissions as defined in § 63.2. The requirements of this subpart do not apply to research and development facilities, as defined in section 112(c)(7) of the Clean Air Act, or to chemical manufacturing process units, as defined in § 63.101, that produce vinyl chloride monomer or other raw materials used in the production of polyvinyl chloride and copolymers.

#### § 63.11870 What is the affected source of this subpart?

(a) This subpart applies to each polyvinyl chloride and copolymers production affected source.

(b) The polyvinyl chloride and copolymers production affected source is the facility wide collection of PVCPU, storage vessels, heat exchange systems, surge control vessels, wastewater and process wastewater treatment systems that are associated with producing polyvinyl chloride and copolymers.

(c) An existing affected source is one for which construction was commenced on or before May 20, 2011, at a major source.

(d) A new affected source is one for which construction is commenced after May 20, 2011, at a major source.

(e) If components of an existing affected source are replaced such that the replacement meets the definition of reconstruction in § 63.2 and the reconstruction commenced after May 20, 2011, then the existing affected source becomes a reconstructed source and is subject to the relevant standards for a new affected source. The reconstructed source must comply with the requirements for a new affected source upon initial startup of the reconstructed source or by April 17, 2012, whichever is later.

#### § 63.11871 What is the relationship to 40 CFR part 61, subpart F?

After the applicable compliance date specified in § 63.11875(a), (b) or (c), an affected source that is also subject to the provisions of 40 CFR part 61, subpart F, is required to comply with the provisions of this subpart and no longer has to comply with 40 CFR part 61, subpart F.